



圖 4.1 SPC-51 集錄系統

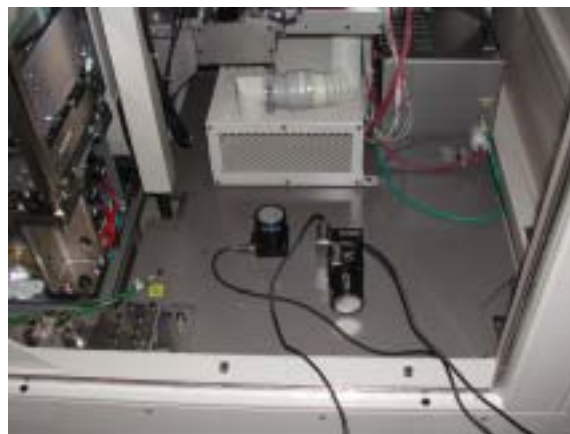


圖 4.2 VSE-15D 速度計

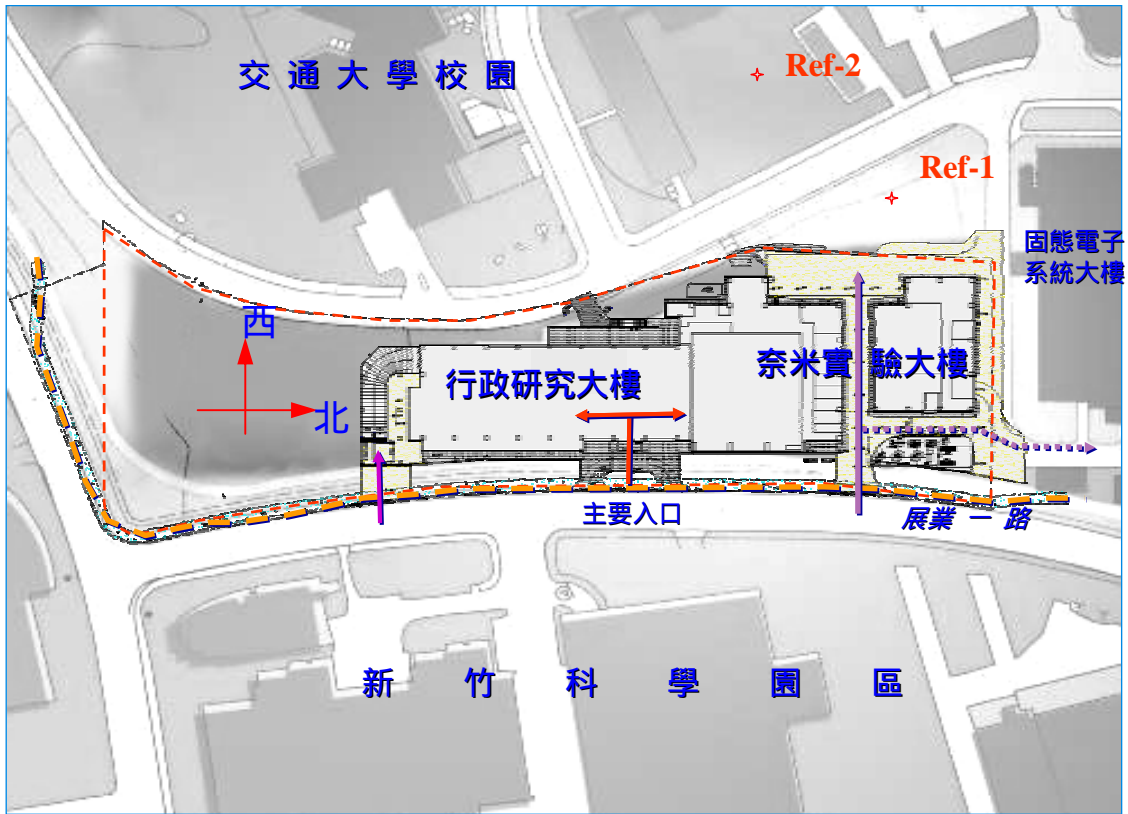


圖 4.3 奈米元件實驗室位置圖

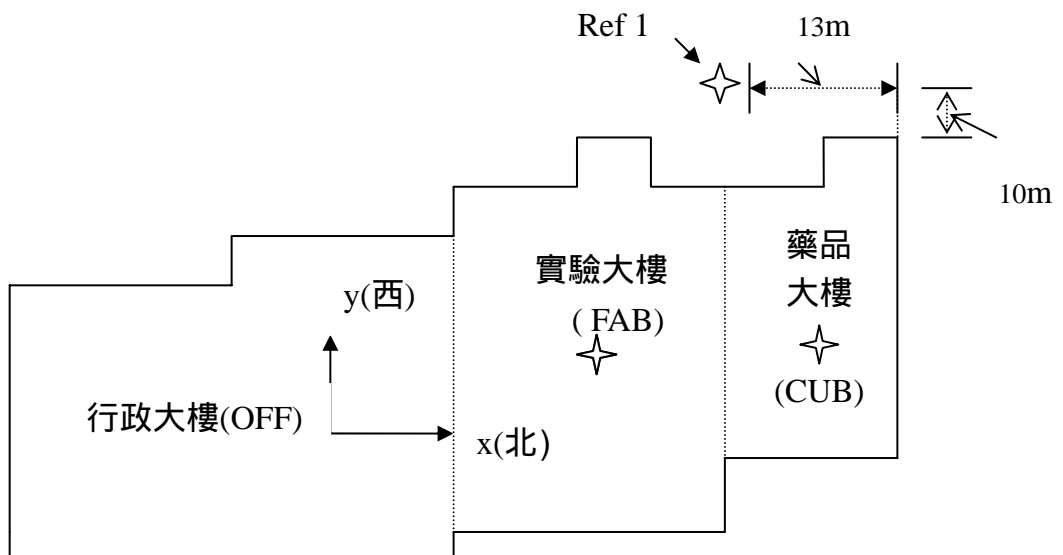


圖 4.4 奈米實驗室平面簡圖



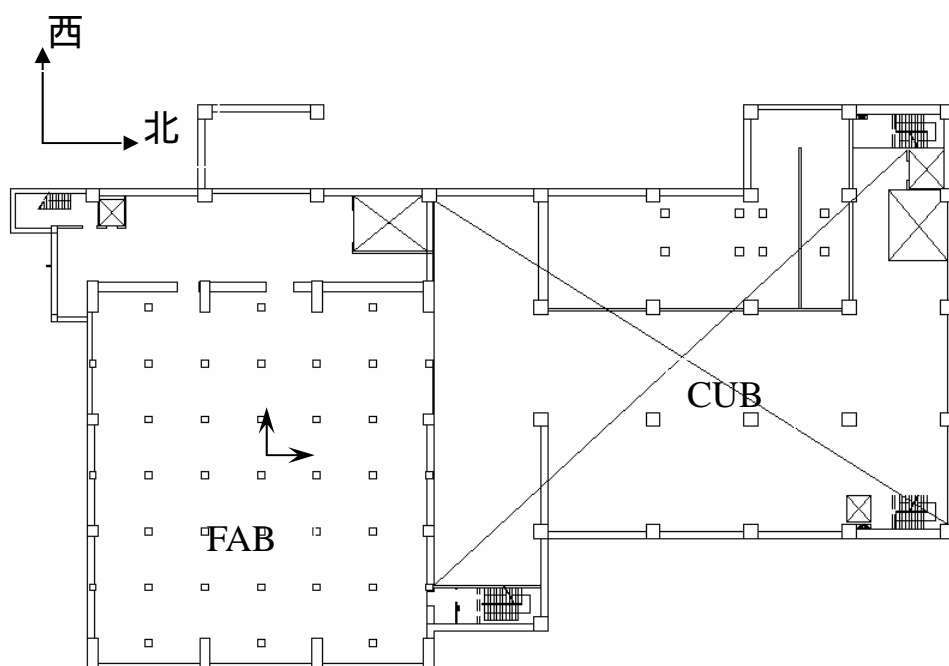


圖 4.5 B1 量測點位

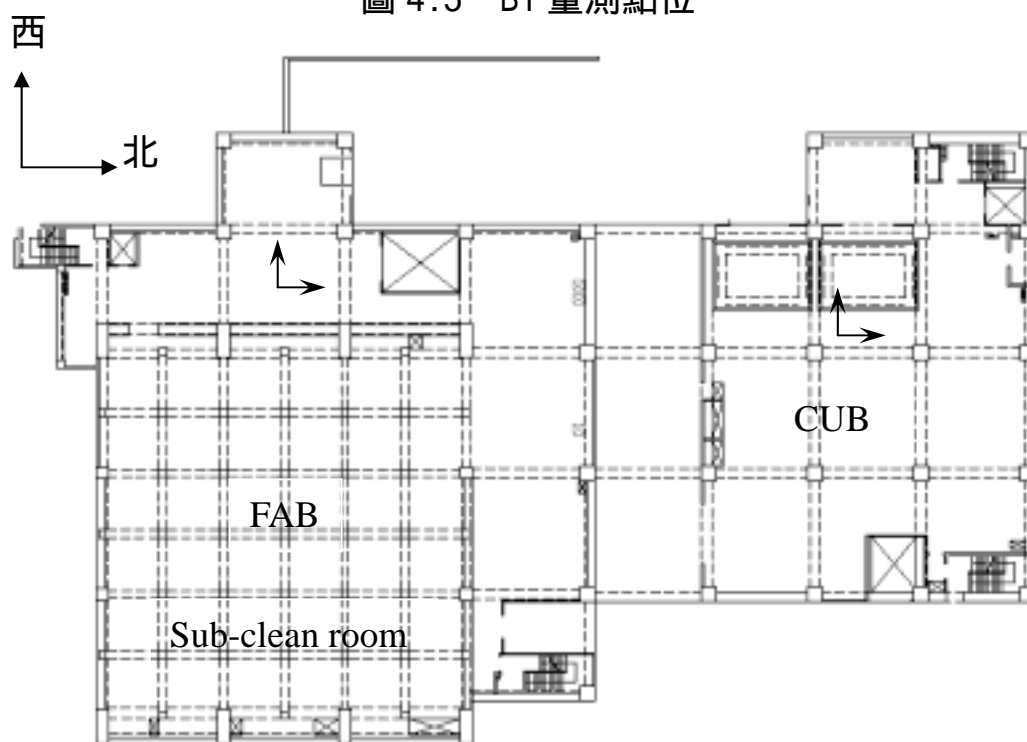


圖 4.6 1F 量測點位



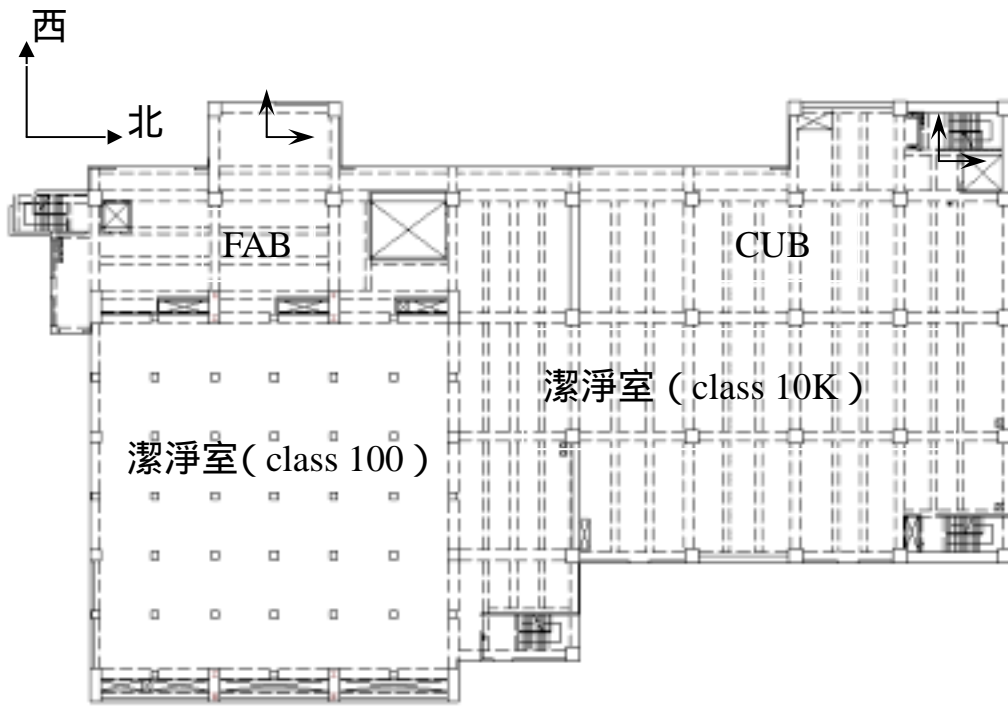


圖 4.7 3F 量測點位

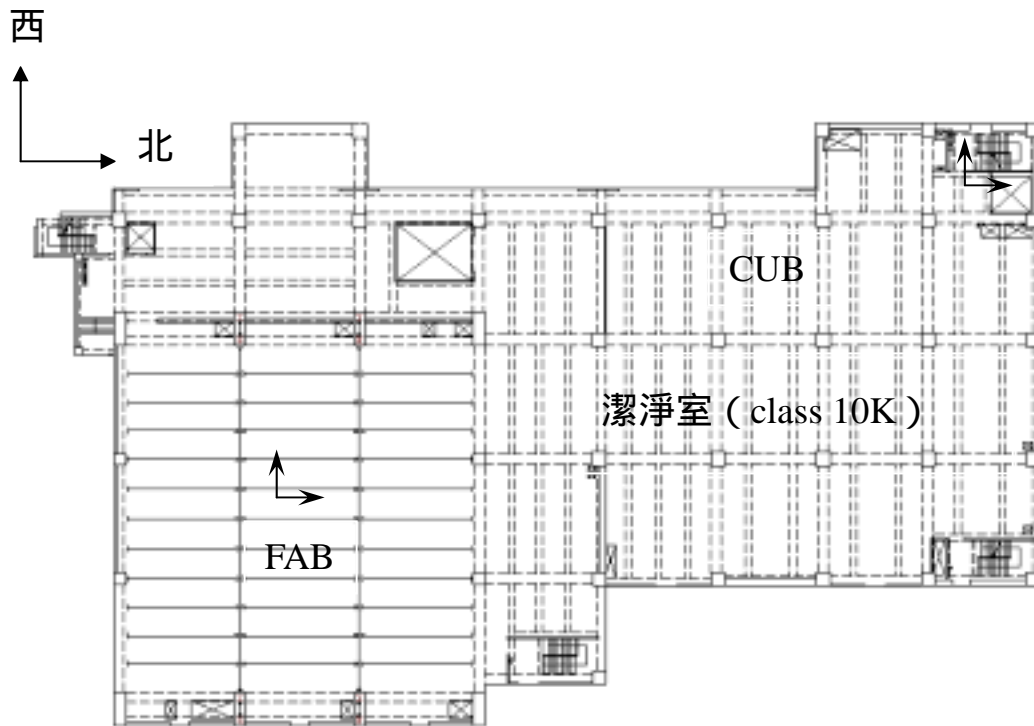


圖 4.8 4F 量測點位

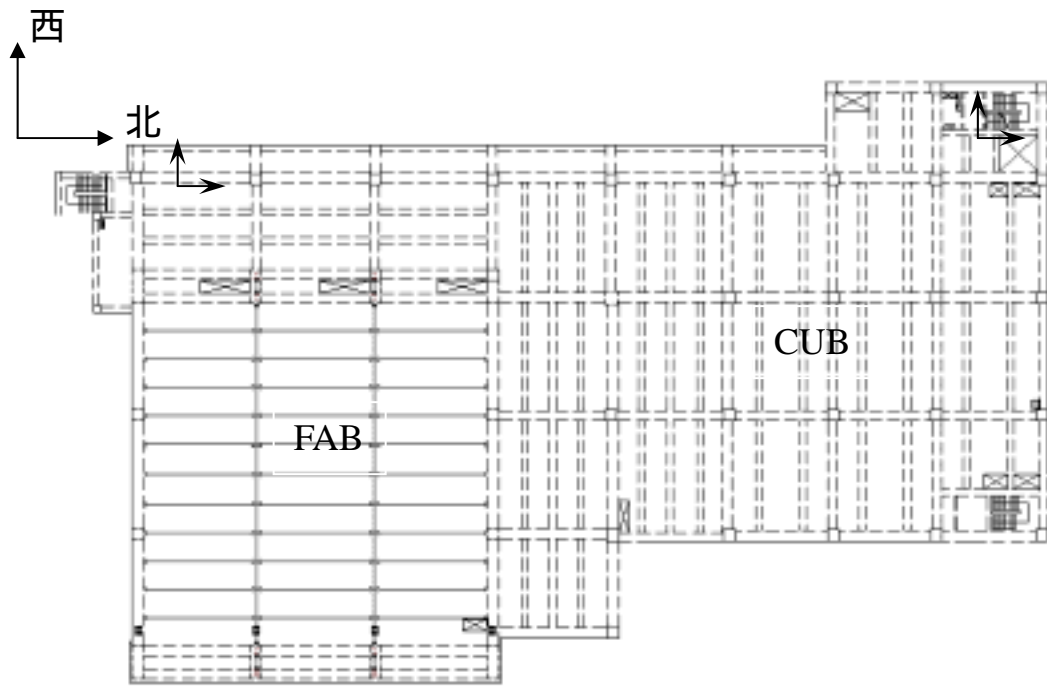


圖 4.9 5F 量測點位

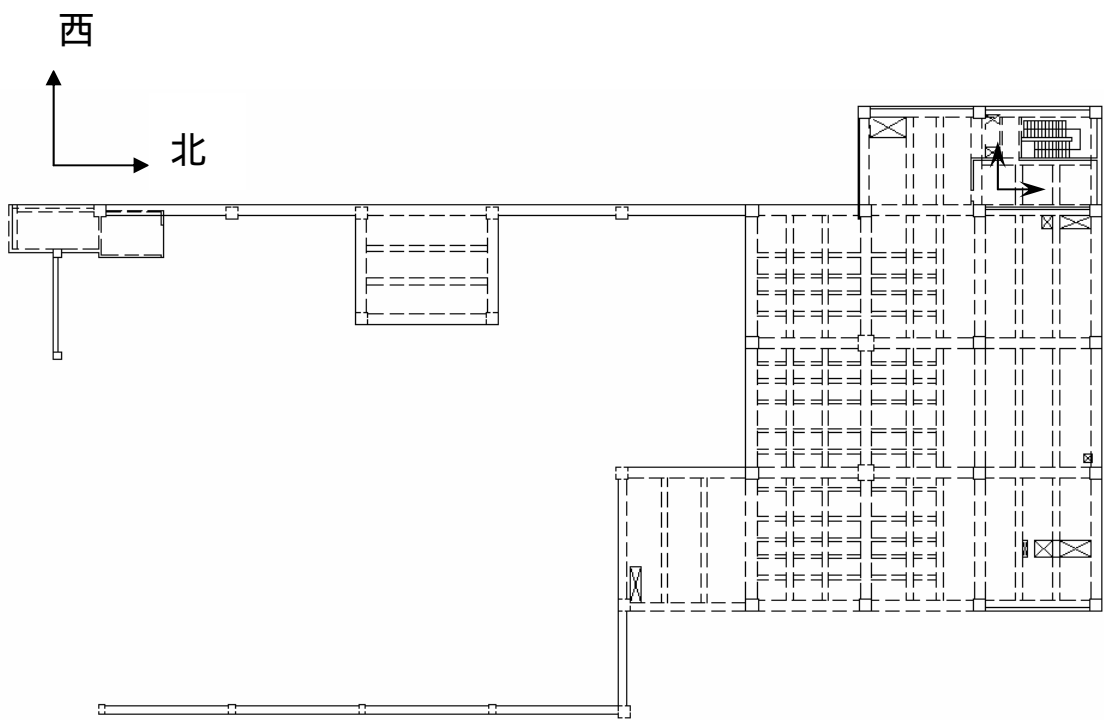


圖 4.10 6F 量測點位





圖 4.11 素地之量測現況



圖 4.12 基礎開挖完成之量測現況



圖 4.13 基礎版完成之量測現況







圖 4.14 FAB 棟完成之量測現況



圖 4.15 通風設備運轉中之現況

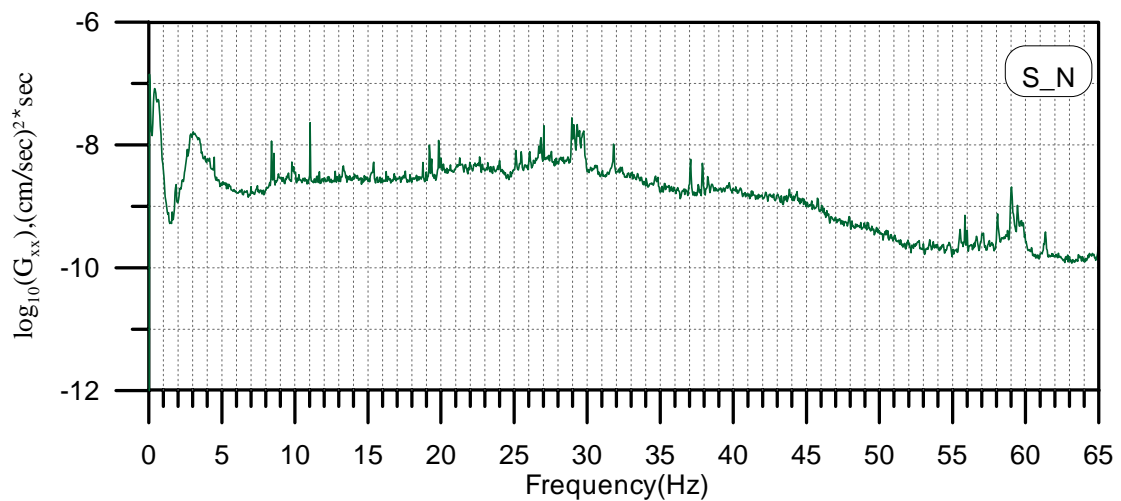
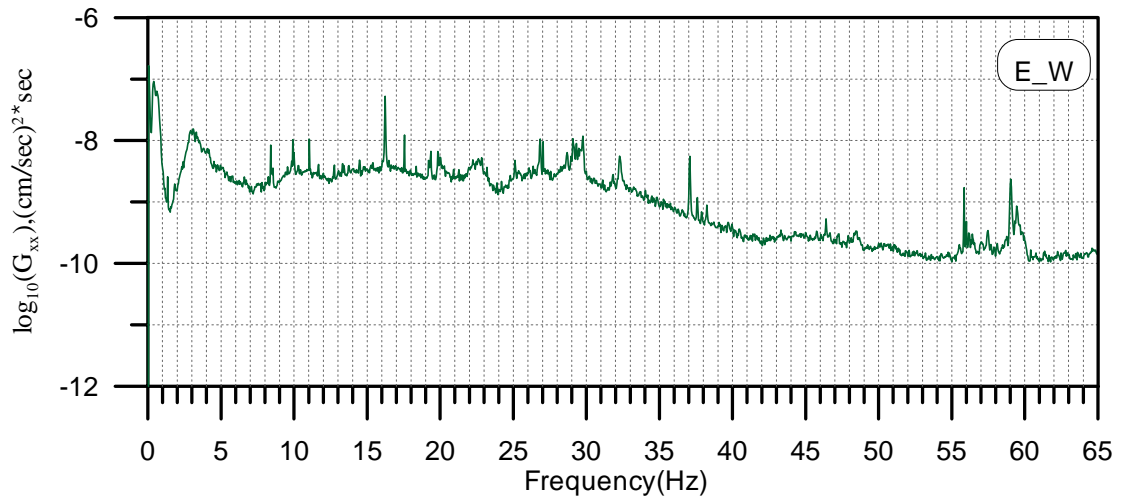
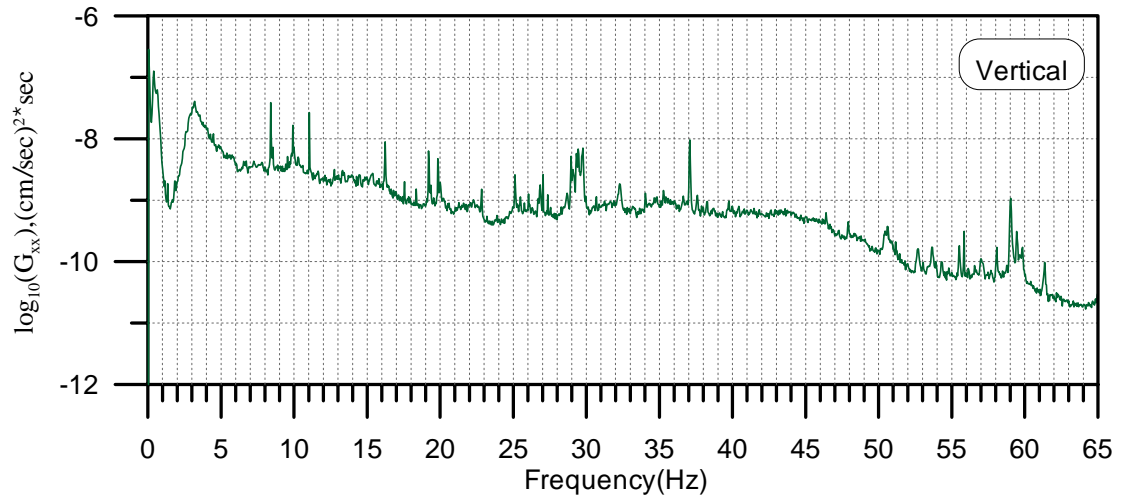


圖 4.16 測站 FAB 第一次量測之能譜圖





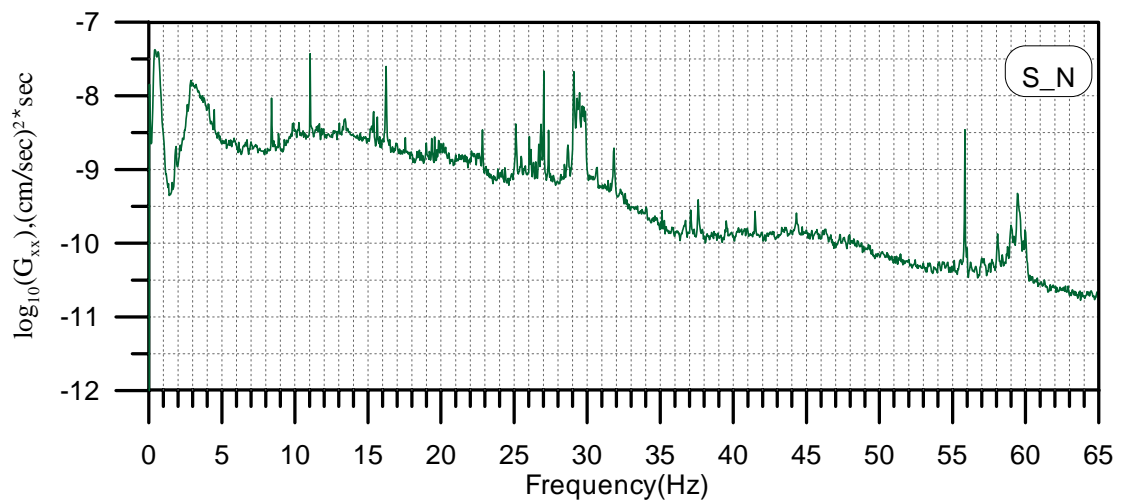
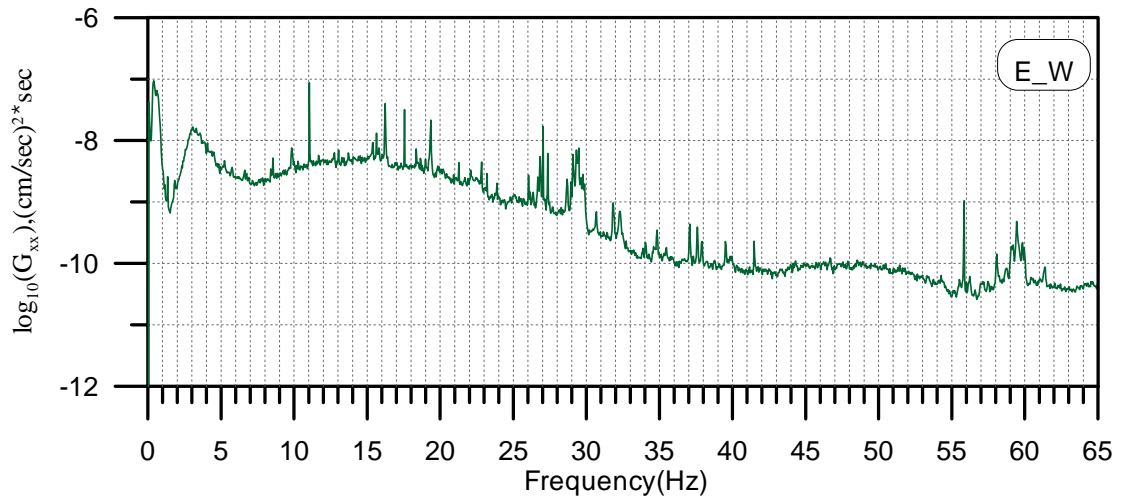
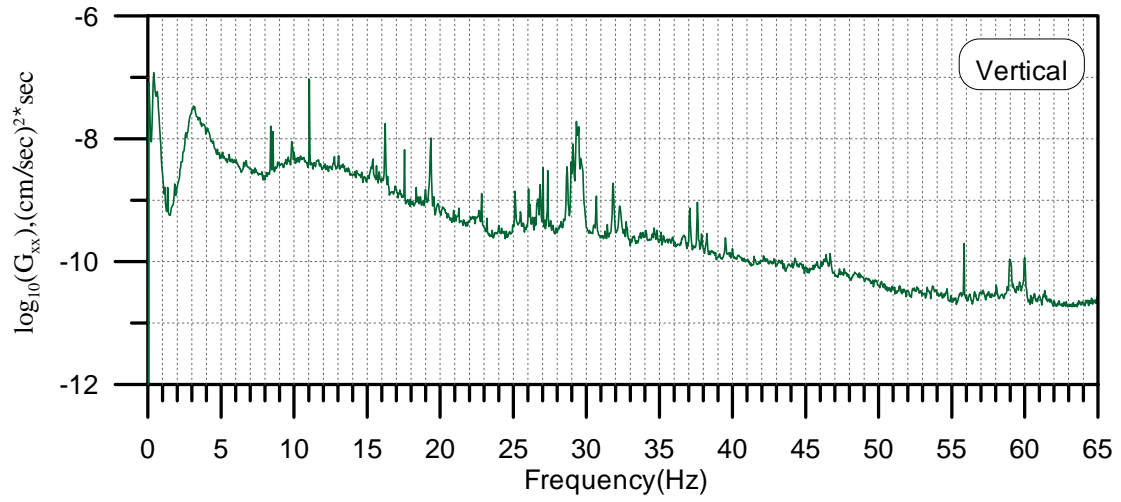
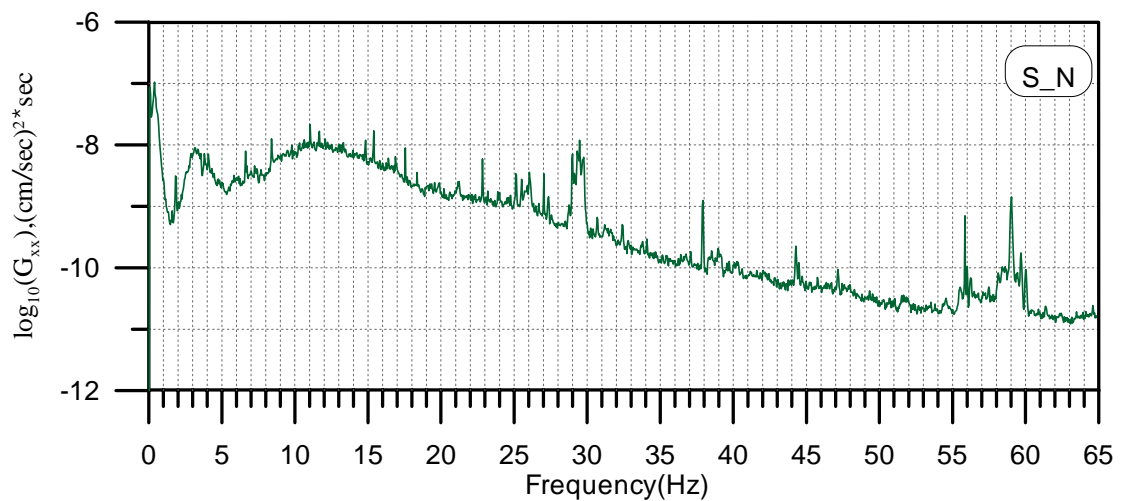
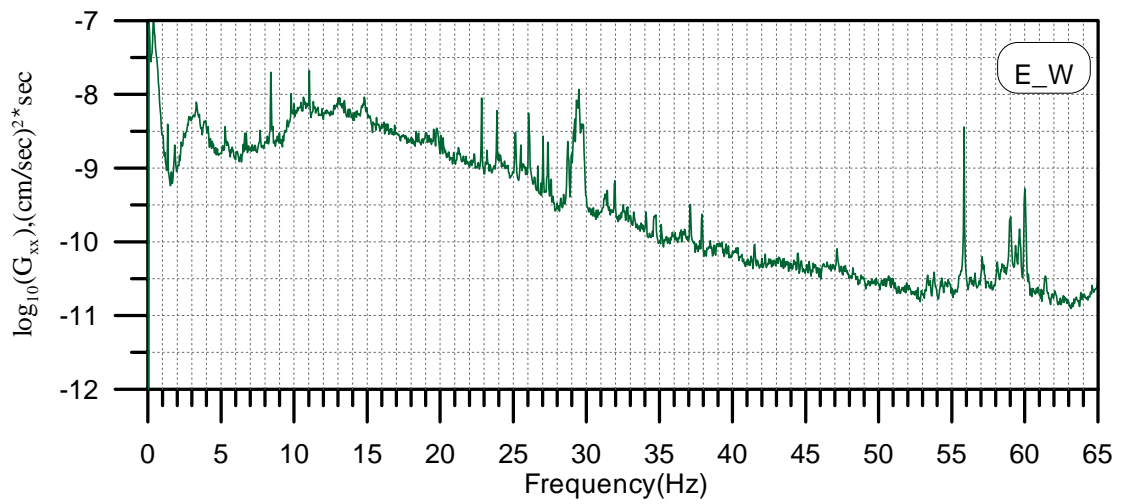
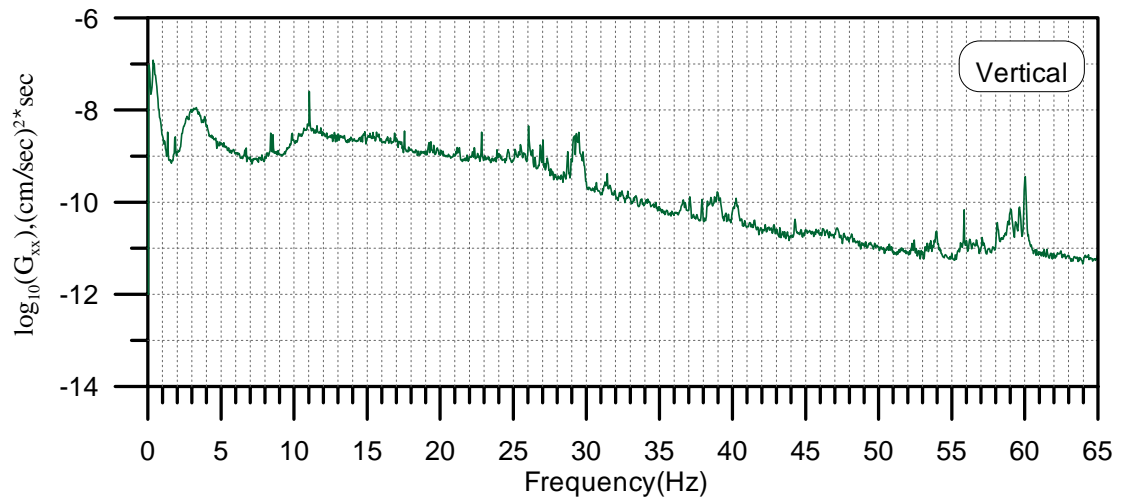


圖 4.17 測站 Ref-1 第一次量測之能譜圖





4.18 測站 Ref-2 第一次量測之能譜圖



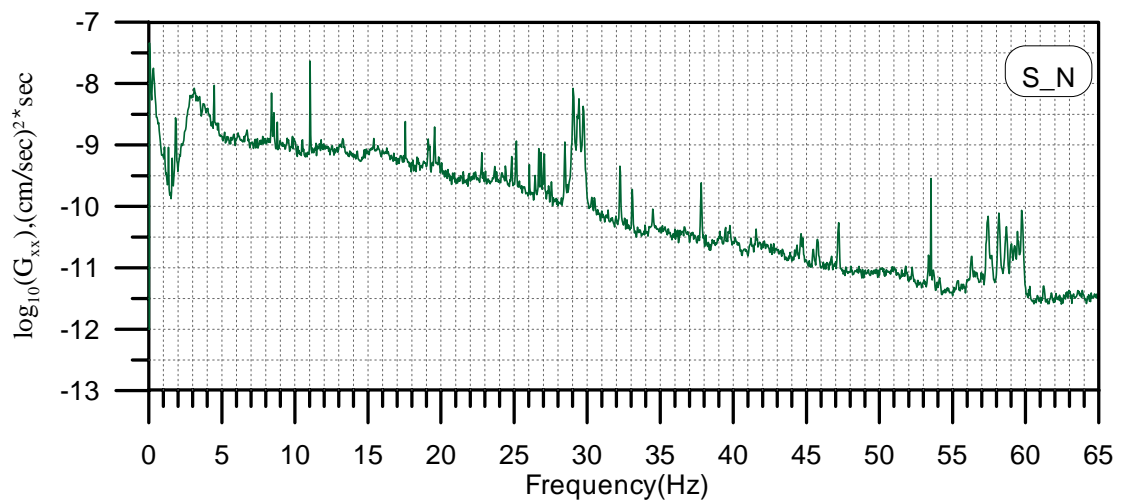
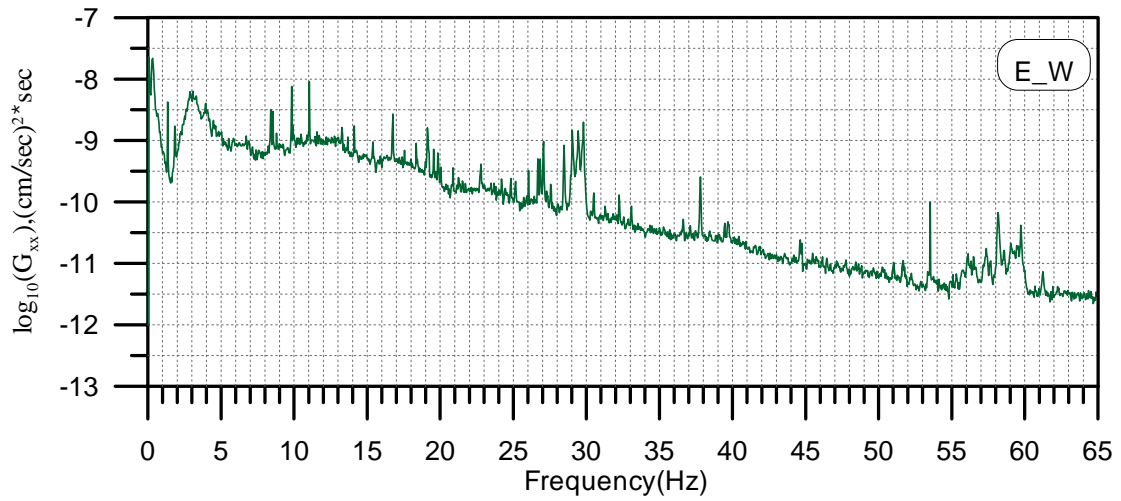
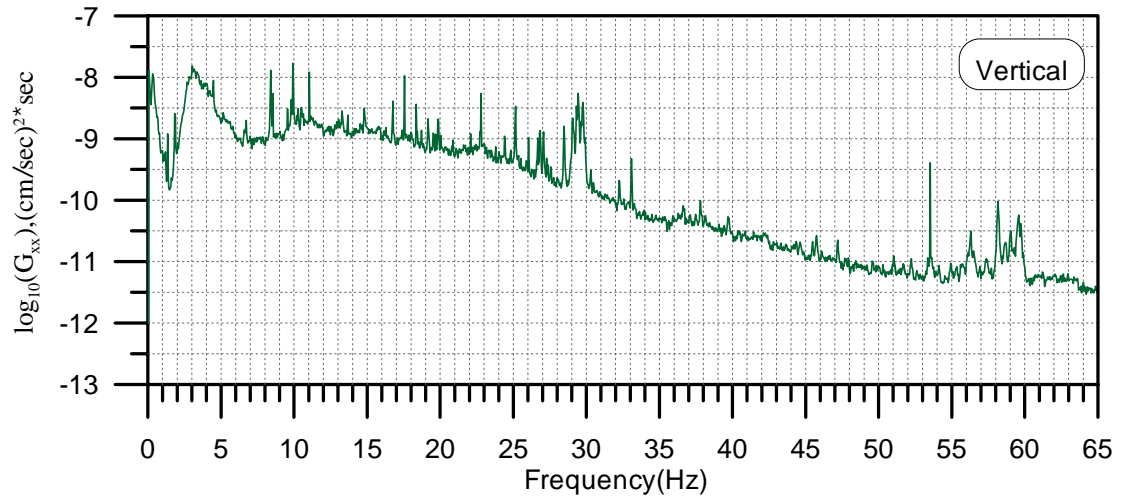


圖 4.19 測站 FAB 第二次量測之能譜圖



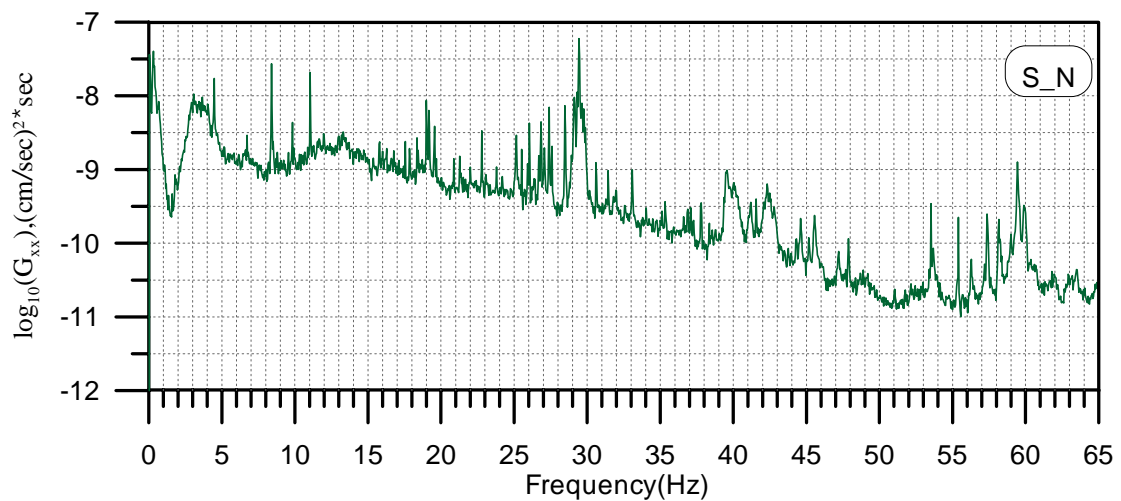
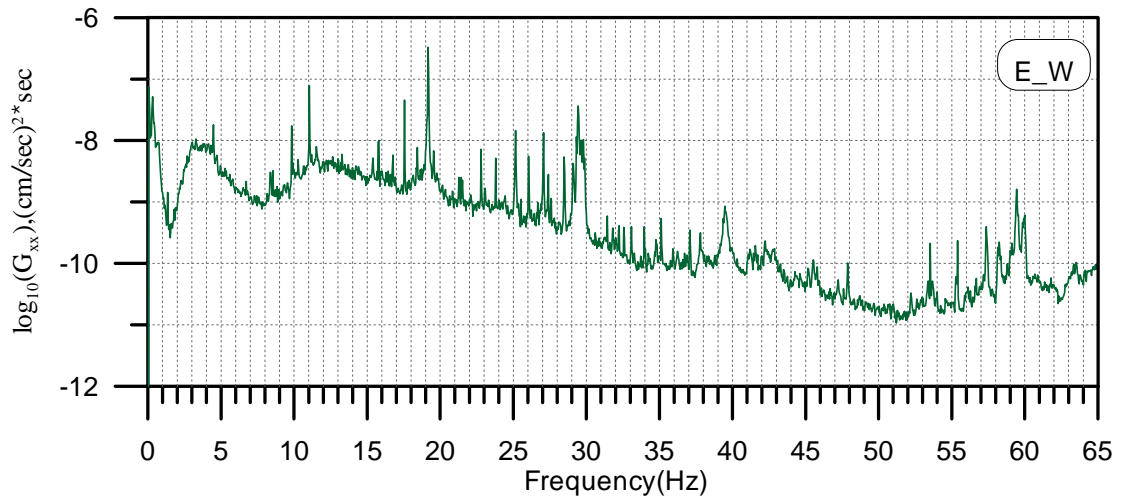
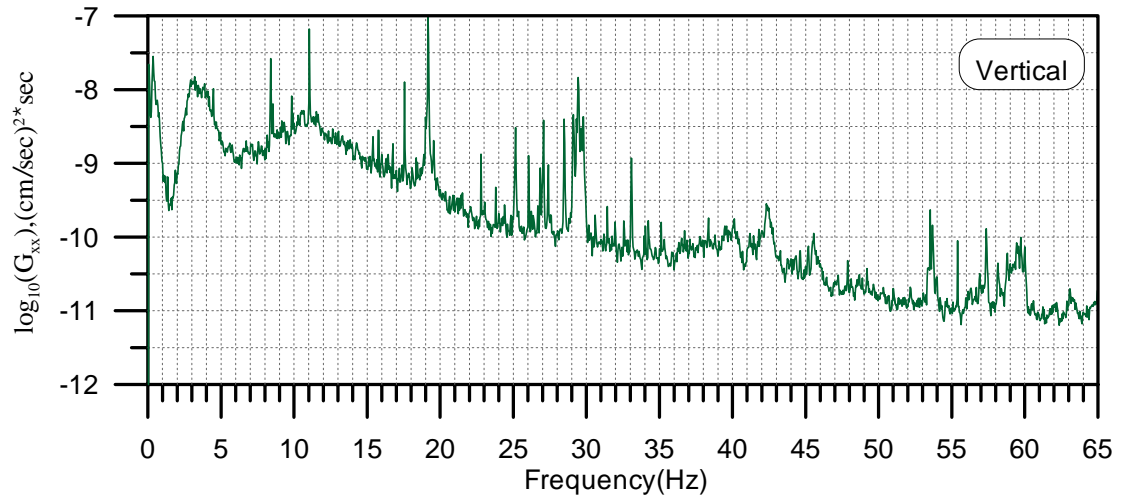


圖 4.20 測站 Ref-1 第二次量測之能譜圖



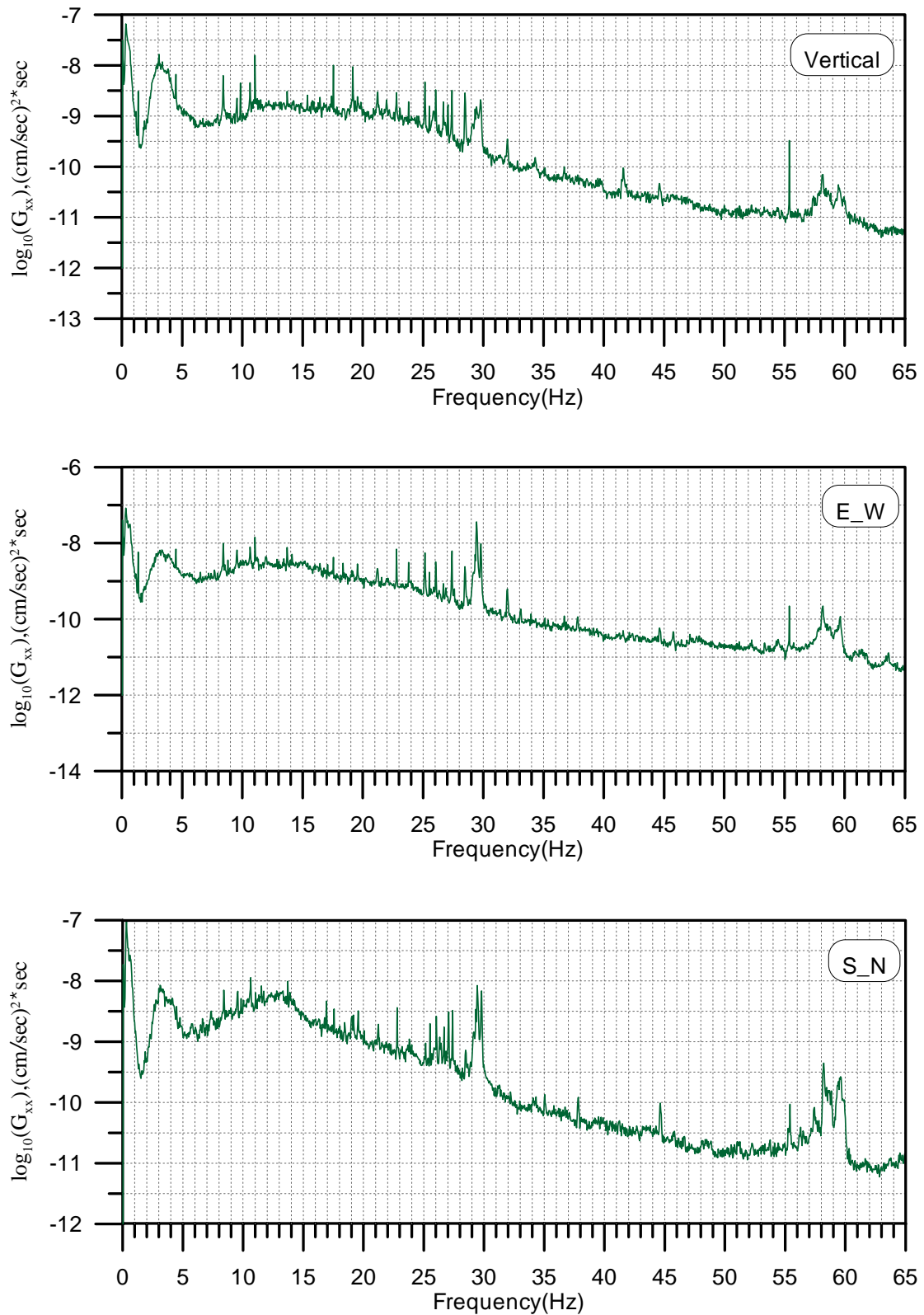


圖 4.21 測站 Ref-2 第二次量測之能譜圖



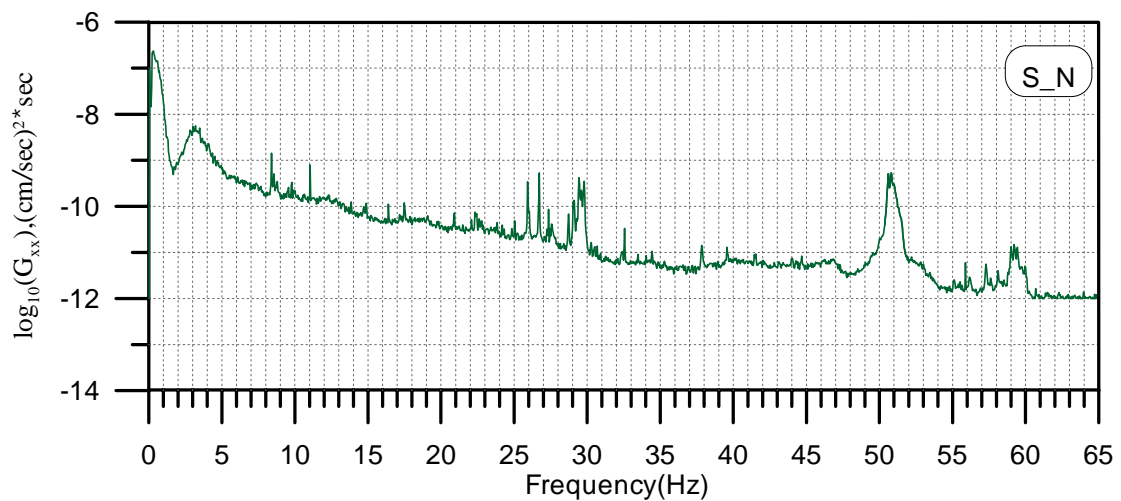
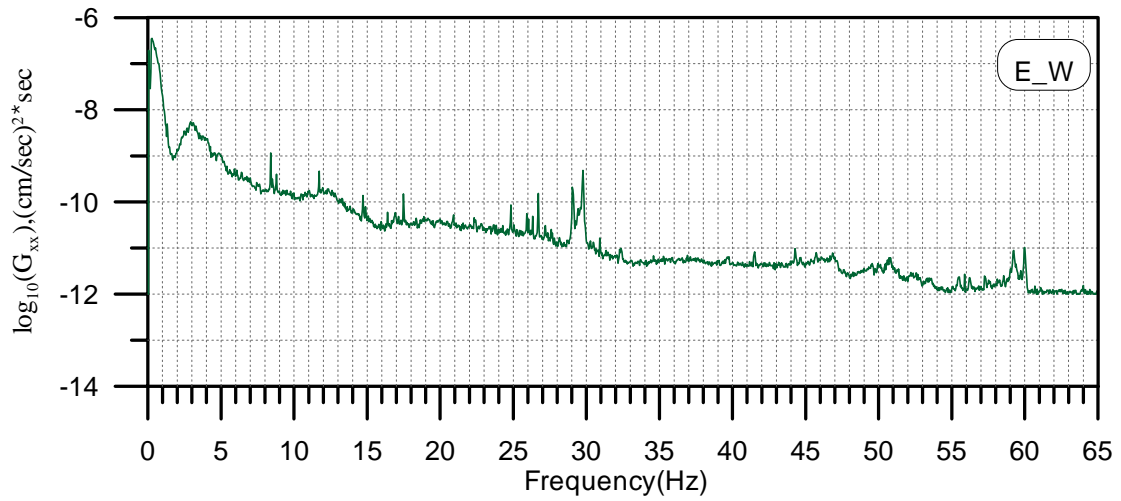
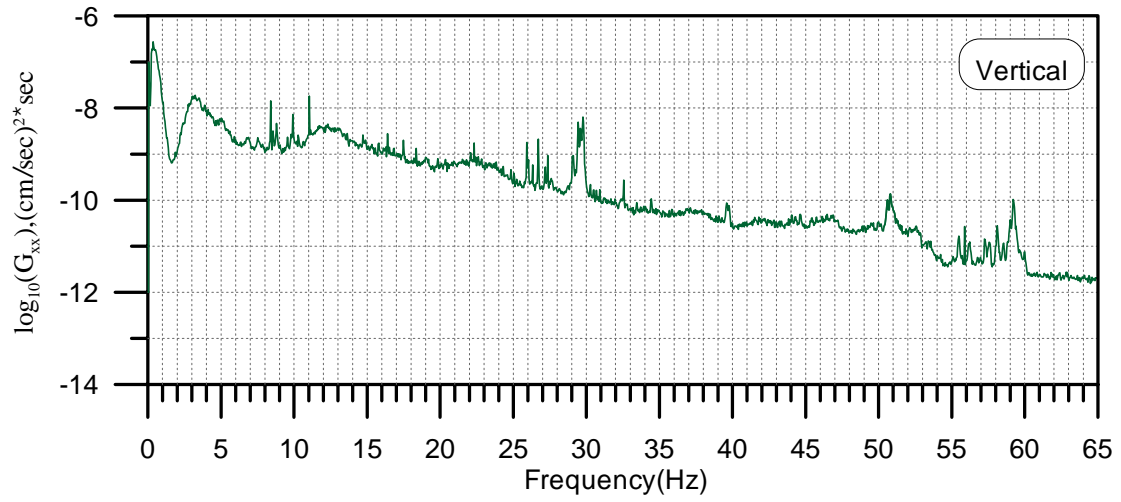


圖 4.22 測站 FAB 第三次量測之能譜圖





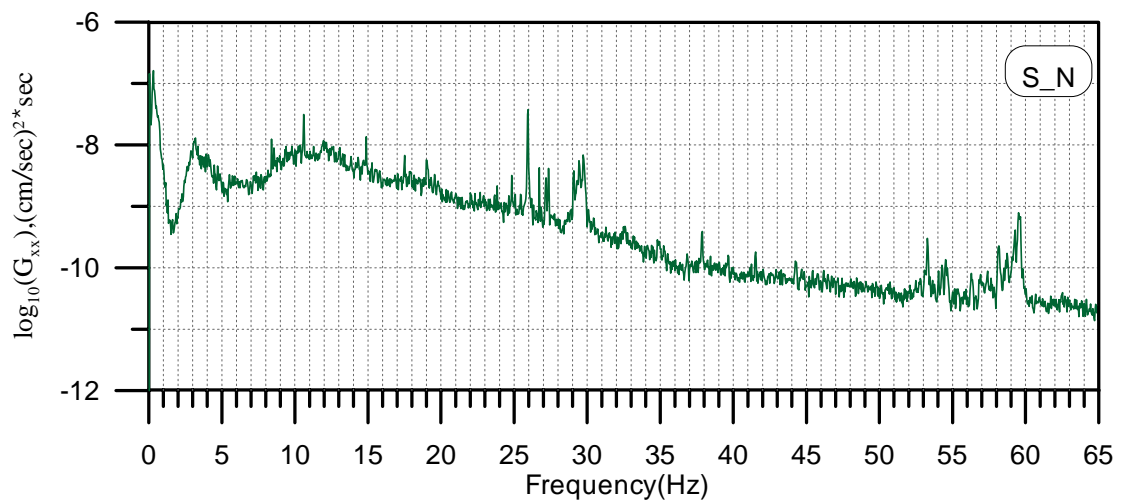
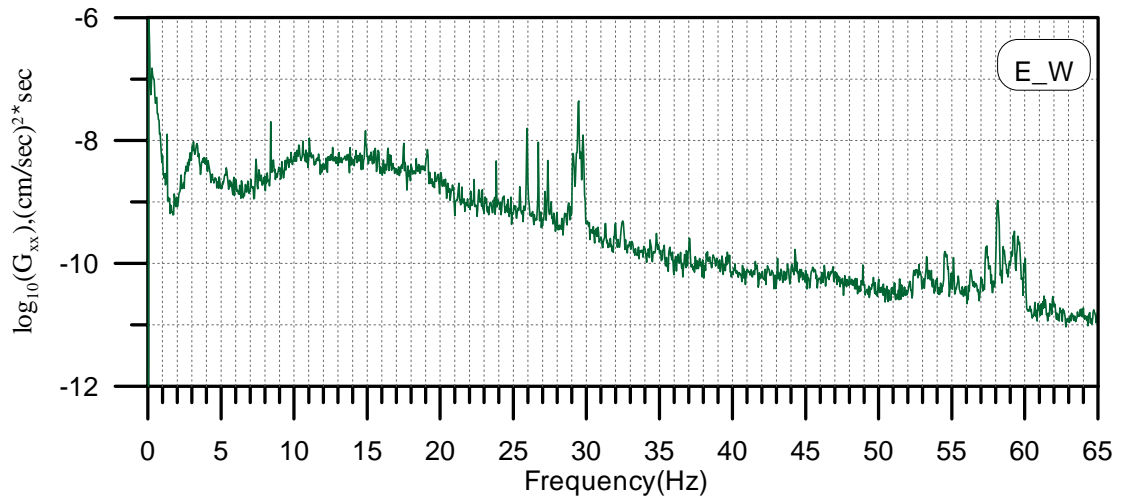
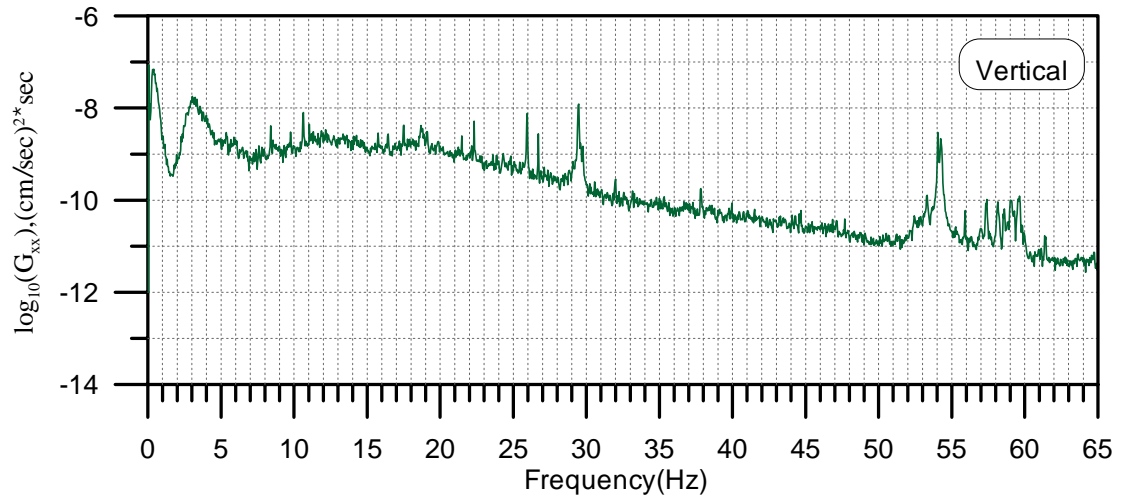


圖 4.23 測站 Ref-1 第三次量測之能譜圖



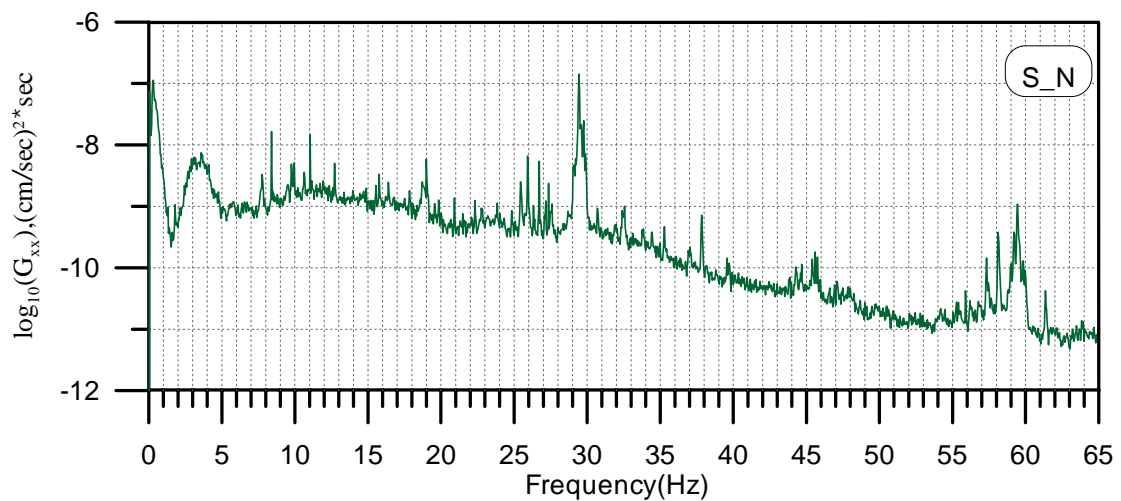
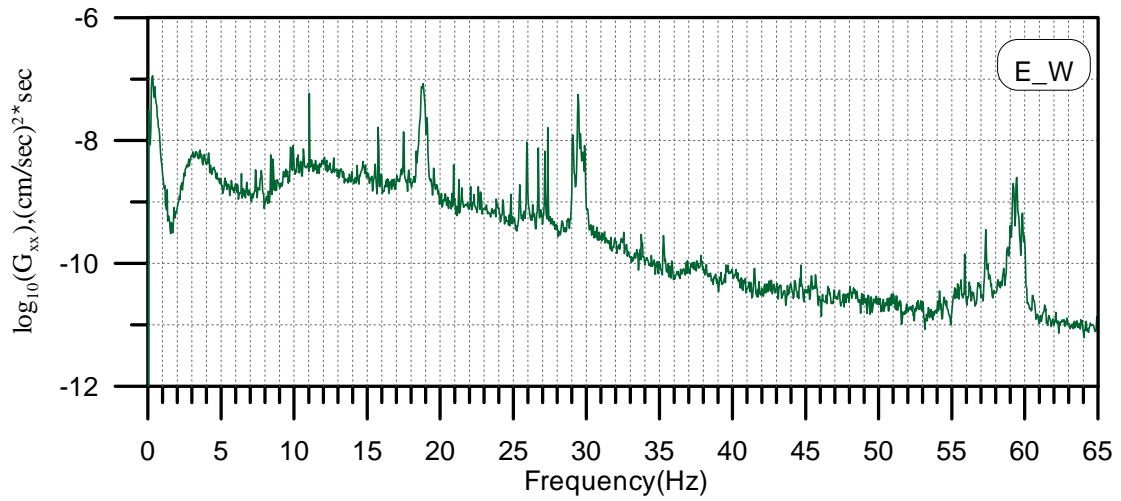
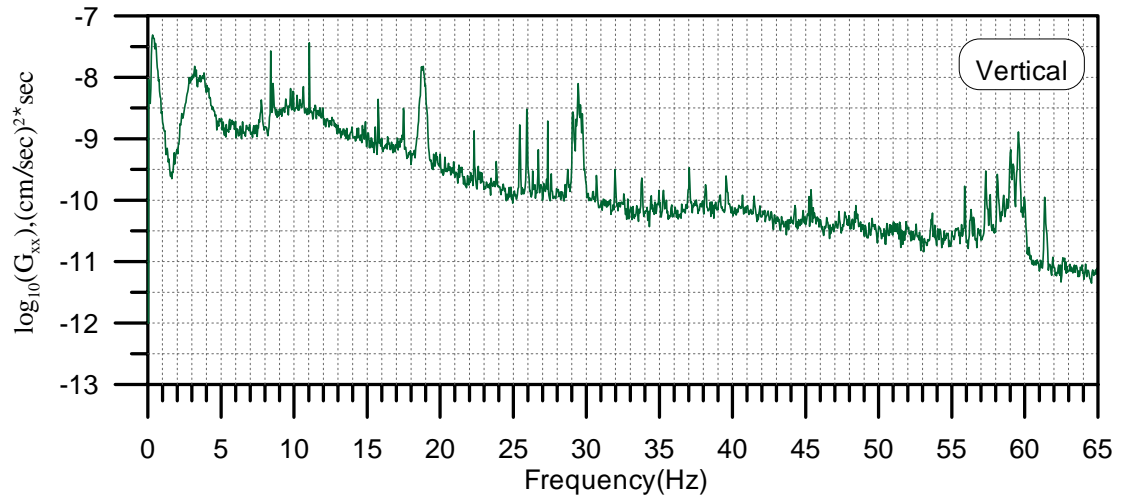


圖 4.24 測站 Ref-2 第三次量測之能譜圖



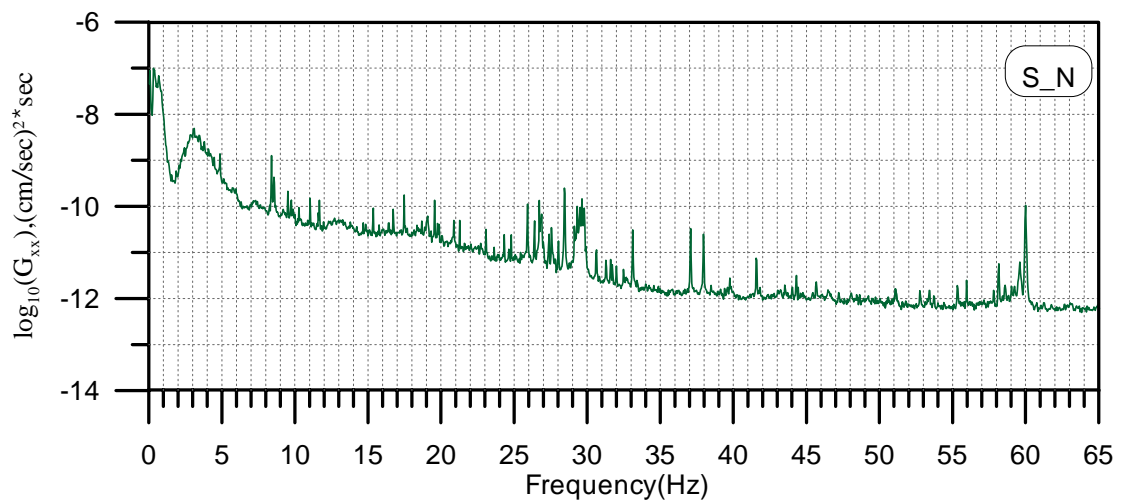
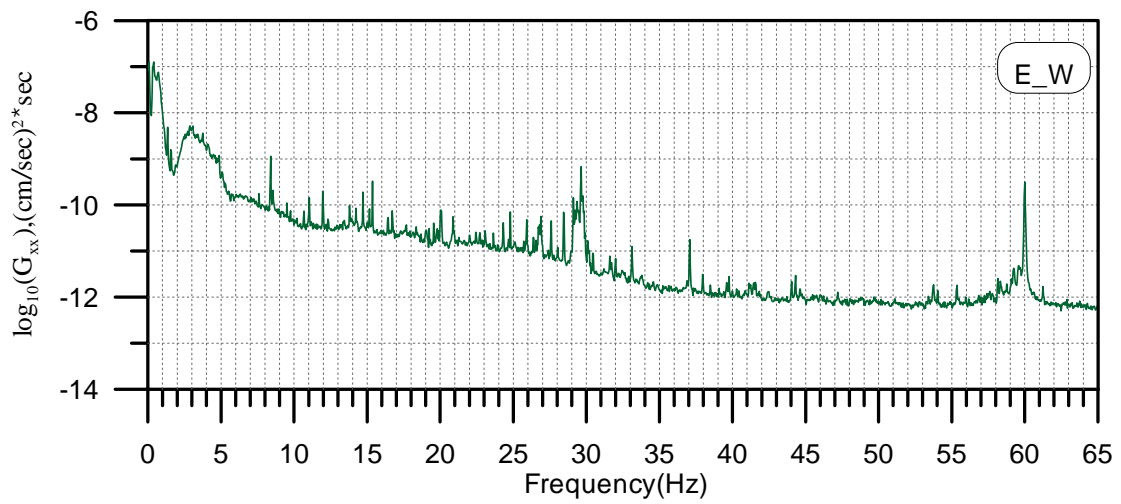
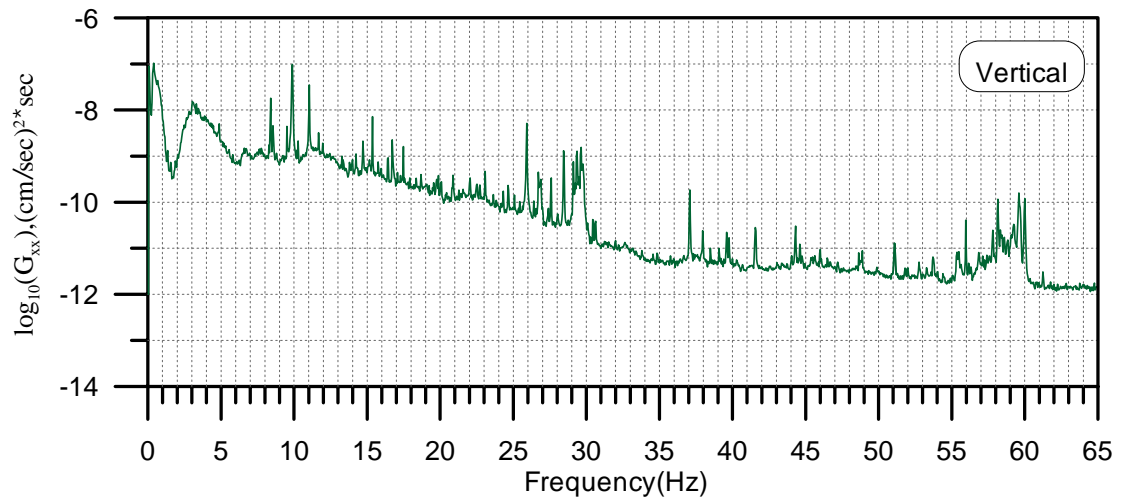


圖 4.25 測站 FAB 第四次量測之能譜圖



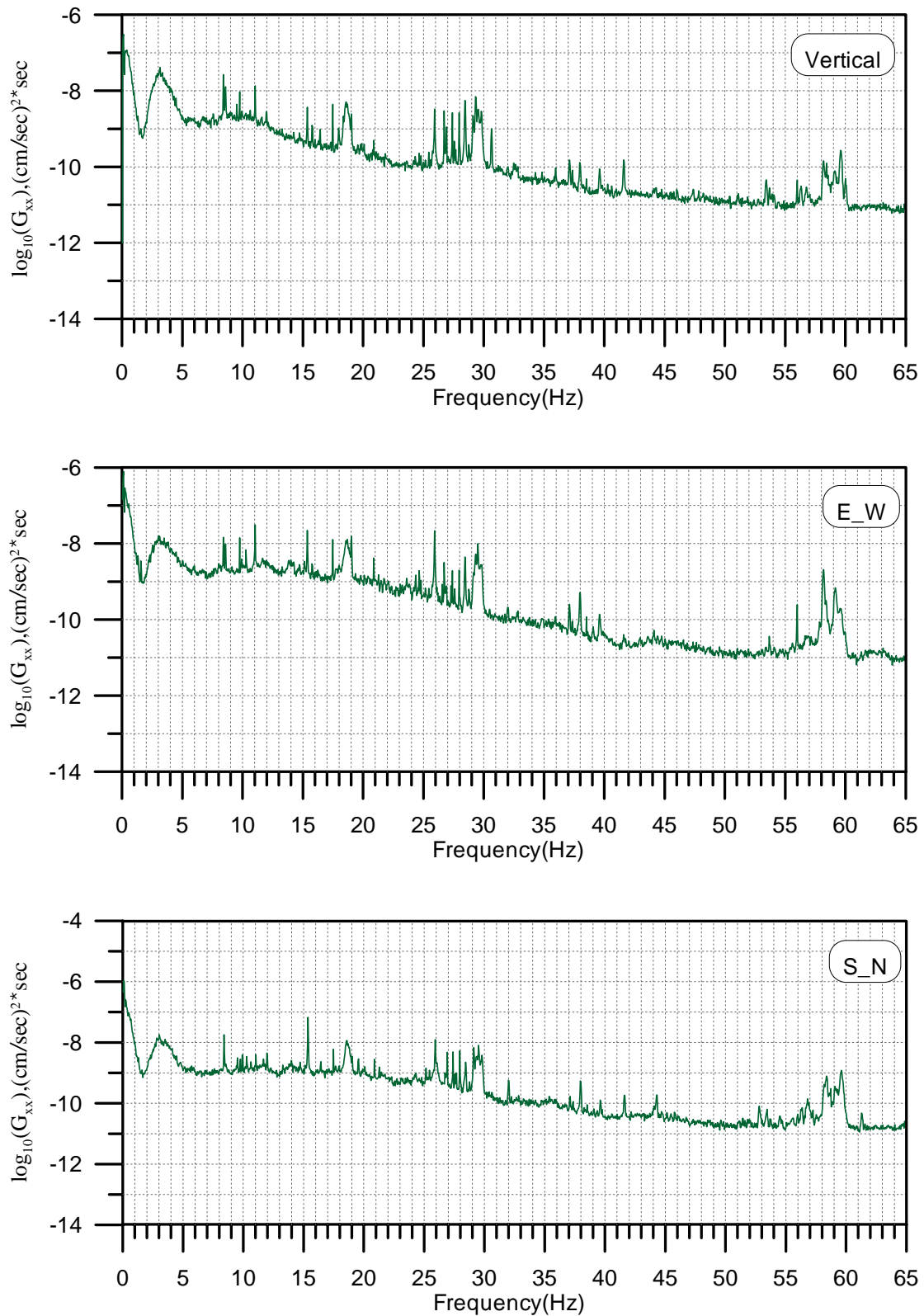


圖 4.26 測站 Ref-1 第四次量測之能譜圖



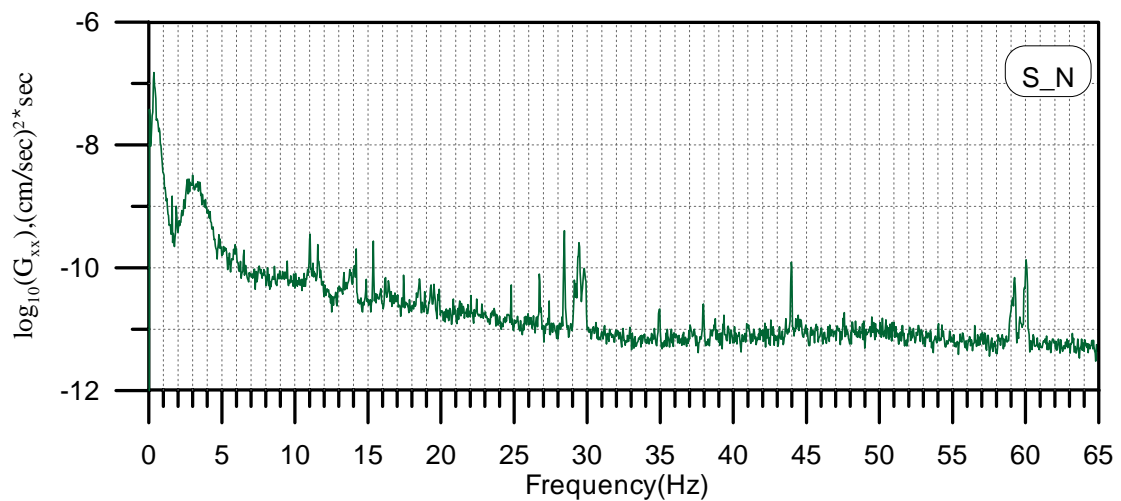
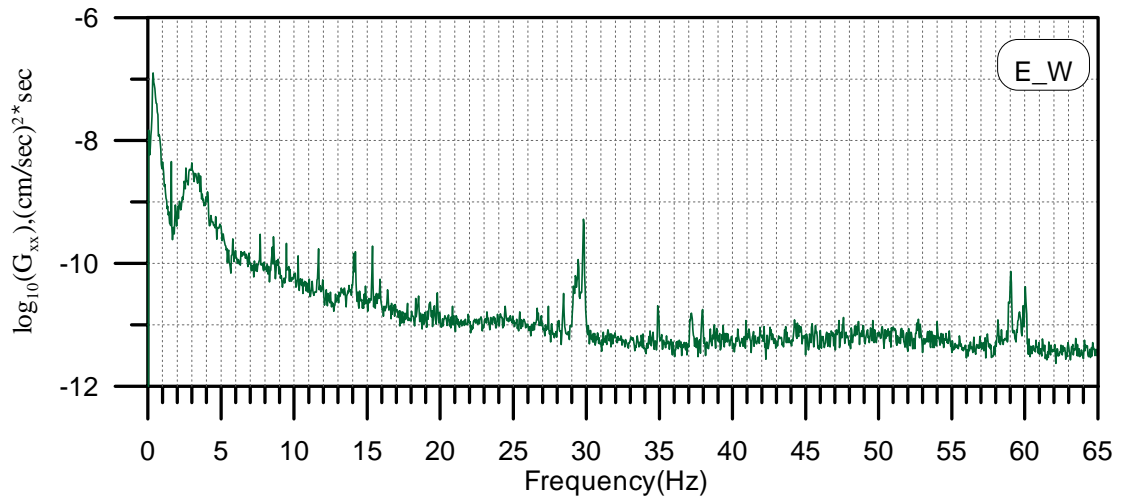
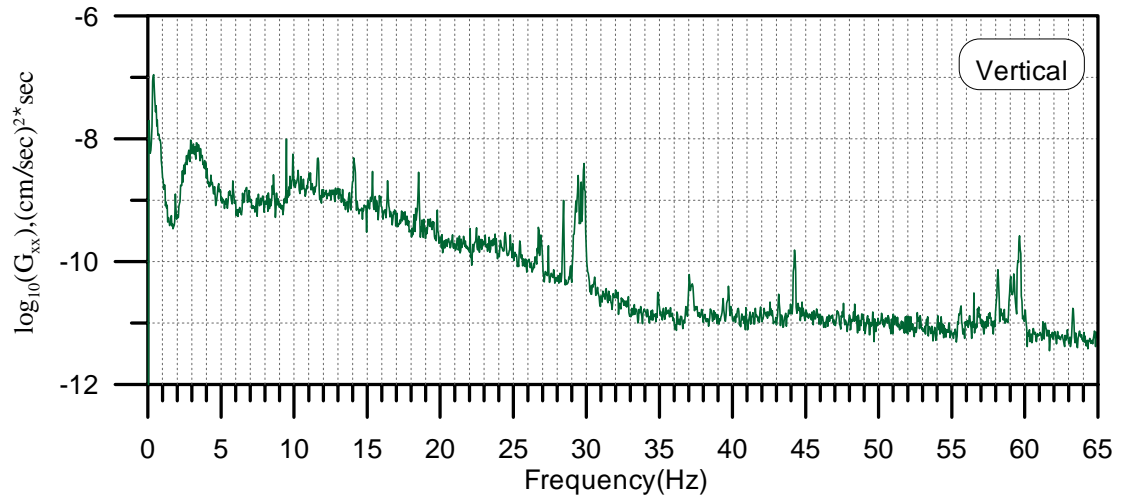


圖 4.27 測站 FAB 於通風設備運轉時量測之能譜圖

